



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Sung-Sok Choi et al.

Group Art Unit: 1763

Application No. 10/813,439

Examiner: Rudy Zervigon

Filed: March 31, 2004

For: APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
 Customer Service Window, Mail Stop Amendment
 Randolph Building
 401 Dulany Street
 Alexandria VA 22314

Sir:

In response to the Office Action of August 25, 2005, Applicants elect the invention of Group I, Claims 1-5, and 9-13. The election is without traverse.

Respectfully submitted,

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